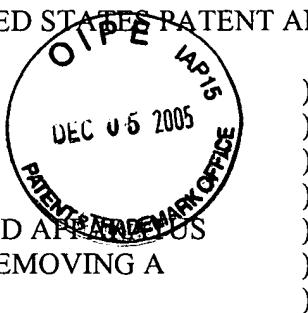


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of  
Keiji Ishibashi  
Serial No. 09/633,002  
Filed: August 4, 2000  
Title: HOT ELEMENT CVD APPARATUS  
AND A METHOD FOR REMOVING A  
DEPOSITED FILM



Examiner: Wesley D. Markham  
Customer No. 00832  
Patent No.: 6,942,892 B1  
Issued: September 13, 2005

REQUEST FOR CORRECTION  
UNDER 37 C.F.R. SECTION 1.323

Certificate  
DEC 08 2005  
of Correction

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A Certificate of Correction under Rule 1.323 in the above-identified patent is respectfully requested in accordance with the enclosed copies of form PTO-1050. The requisite fee of \$100.00 is included herewith.

Respectfully submitted,

Anthony Niewyk  
Registration No. 24,871

Attorney for Applicant

AN/mld

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Date: November 30, 2005

Enc. PTO-1050 (2)  
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12/06/2005 SSITHIB1 00000019 6942892

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100.00 OP

**UNITED STATES PATENT AND TRADEMARK OFFICE**  
**CERTIFICATE OF CORRECTION**

PATENT NO : 6,942,892 *B1*

DATED : SEPTEMBER 13, 2005

INVENTOR(S) : Keiji Ishibashi

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title Page, at (73) assignee information, please add the following assignee:

Japan Science and Technology Corporation, Saitama Japan

MAILING ADDRESS OF SENDER: Anthony Niewyk, Reg. No. 24,871  
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111 East Wayne Street, Suite 800  
Fort Wayne, IN 46802

PATENT NO. 6,942,892

No. of additional copies



DEC 09 2005

**UNITED STATES PATENT AND TRADEMARK OFFICE**  
**CERTIFICATE OF CORRECTION**

PATENT NO : 6,942,892 *β*

DATED : SEPTEMBER 13, 2005

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